

Substitute Form PTO-1449 (Modified) Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 12732-189001	Application No. 10/735,767
	Applicant Hideaki Kuwabara et al.		
	Filing Date December 16, 2003	Group Art Unit 2822	

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
KP	AA	2001/0040298	11/15/2001	Baba			01/04/2001
KP	AB	2002/0100941	08/01/2002	Yonehara			01/31/2002
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Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
KP	AK	DE-10047963	03/29/2001	Germany			ABS	
KP	AL	EP-1017100	07/05/2000	Europe			In English	
KP	AM	EP-1229582	08/07/2002	Europe			In English	
KP	AN	JP-11-020360	01/26/1999	Japan			ABS	
	AO							

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
KP	AP	European Search Report dated August 22, 2006 for European Patent Office Application No.: 03029012.6, 5 pages
KP	AQ	Zhang, X. et al., "Thermal Conductivity and Diffusivity of Free-Standing Silicon Nitride Thin Films"; <i>Review of Scientific Instruments</i> , Vol. 66, No. 2, Part 1; pp. 1115-1120; 02/1995
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	AS	

Examiner Signature /Kevin Picardat/	Date Considered 10/02/2006
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